



Docket No. F-7337

#9 EOT./AMDT. B
2815 \$
10/23/03
Muelish

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shigeki SAKAI, et al.
Serial No. : 10/090,851 ✓
Filed : March 4, 2002 ✓
For : SEMICONDUCTOR NONVOLATILE STORAGE ELEMENT AND METHOD OF FABRICATING THE SAME
Group Art Unit : 2815
Examiner : Jesse A. Fenty
Confirmation No. : 5906
Customer No. : 000028107

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H F RUSCHMANN
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Herbert F. Ruschmann
(Name)

H F Ruschmann
(Signature)

AMENDMENT

MAILSTOP FEE AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

10/10/2003 CCHAU1 00000146 101250 10090851
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INTRODUCTORY COMMENTS:

Sir:

In response to the Office Action of June 6, 2003, please amend the above-identified patent application as follows:

Amendments to the Specification begin on page 3 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this paper.

Remarks/Arguments begin on page 8 of this paper.